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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

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|----------|-------------|-------|----------|------|----------|
| APPL NUM | FILING DATE | CLASS | SUBCLASS | GAU | EXAMINER |
| 10014387 | 12/11/2001 | 204 | 298.4 | 1753 | CANTeLMO |

**APPLICANTS: Shi Xu; Tay Beng; Flynn David; Tan Hong; Fulton Michael;

**CONTINUING DATA VERIFIED:

This application is a CIP of 08/894,419 11/21/1997 ABN

** FOREIGN APPLICATIONS VERIFIED:

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| | | |
|--|---|----------------------------------|
| PG-PUB | DO NOT PUBLISH <input type="checkbox"/> | RESCIND <input type="checkbox"/> |
| Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no | | ATTORNEY DOCKET NO |
| 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no | | GWS/18240CIP |
| Verified and Acknowledged Examiners's initials | | |
| TITLE : Filtered cathode arc source deposition apparatus | | |

U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)

| | | | |
|--|-----------|----------------------|----------------------|
| NOTICE OF ALLOWANCE MAILED | | CLAIMS ALLOWED | |
| | | Total Claims | Print Claim for O.G. |
| Assistant Examiner | | DRAWING | |
| ISSUE FEE | | Sheets Drwg. | Figs. Drwg. |
| Amount Due | Date Paid | Print Fig. | |
| Primary Examiner | | Application Examiner | |
| <input type="checkbox"/> TERMINAL DISCLAIMER | | PREPARED FOR ISSUE | |
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